IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/928,172 Filing Date August 9, 2001	1/1/1/
Application Serial No	(43/8
Filing Date August 9, 2001	1/2/
Inventor	•
Assignee Micron Technology, Inc.	
Group Art Unit	
Examiner	
Attorney's Docket No	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
References — See Attached Form PTO-1449

Physical Vapor Deposition Target Constructions

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filled within three months of the filling date of the application or before the mailing date of a first Office Action, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filling this information disclosure statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

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Respectfully submitted, APR 3 2002

TECHNOLOGY CENTER 2800

David G. Latwesen, Ph.D. Reg. No. 38,533

Dated

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.	09/928,172
Filing Date	August 9, 2001
Inventor	
Assignee	. Honeywell International Inc.
Group Art Unit	2823
Examiner	
Attorney Docket No	
Title: Physical Vapor Deposition Target Constructions	

Assistant Commissioner for Patents Washington, D.C. 20231

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

- I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9318 on the date shown below:
 - 1. Certificate of Facsimile
 - 2. Supplemental Information Disclosure Statement w/PTO-1449 and copies of the cited references

Dated: 4-3-02	By: Shime M. white
	Jaime M. White
	Telephone No. (509) 624-4276

NUMBER OF PAGES IN FACSIMILE: _____20___

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